



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79882

Yasuaki TSUCHIYA, et al.

Appln. No.: 10/777,089

Group Art Unit: 1755

Confirmation No.: 4112

Examiner: Michael A. MARCHESCHI

Filed: February 13, 2004

For: CHEMICAL MECHANICAL POLISHING SLURRY

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 9, 2005, please amend the above-identified application as follows on the accompanying pages. A Petition for a one month extension of time is being concurrently filed making a response timely by September 9, 2005.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	5